

**School of Mechanical Engineering and Computer Science**  
**Mech 450: Advanced Topics for Nanoscience and Technology**

<b>Catalog Data:</b>	<b>Mech 450 Advanced Topics for Nanoscience and Technology</b> 3 credits Introduces quantum mechanics, physics in low dimensional structures and materials; hands-on experience with scanning probe microscope. Credit not granted for both Mech 450 and Mech 550.
<b>Class Schedule:</b>	Two 50-minute lecture sessions per week, for one semester.
<b>Laboratory Schedule:</b>	One three hour lab session per week, for one semester.
<b>Prerequisites by Course:</b>	Mech 431 or c//.
<b>Prerequisites by Topic:</b>	Basic physics (mechanics and electromagnetics), introductory chemistry (physical chemistry), basic semiconductor devices
<b>Required Texts:</b>	<ol style="list-style-type: none"> <li>1. Streetman, Banerjee, "Solid State Electronic Devices" Fifth edition, Prentice (Text of Mech 431)</li> <li>2. Hall Keith Barnham and Dimitri Vvedensky, Editors, "Low Dimensional Semiconductor Structure", Cambridge University Press</li> </ol>
<b>Course Coordinator:</b>	Dr. Daniel Chiang
<b>Course Objectives:</b>	<ol style="list-style-type: none"> <li>1. Understand charge carrier transport phenomena by applying the principles of quantum mechanics.</li> <li>2. Learn the principles of low dimensional structures and devices of traditional and polymer semiconductors.</li> <li>3. Understand various operational modes of scanning probe microscopes (SPM), including STM, STS, SFM, SFS.</li> <li>4. Advanced topics for nanoscale materials or devices (Field emission nanorod array and carbon nanotubes).</li> <li>5. Use SPM to characterize nanoscale material or device properties.</li> <li>6. Use TCAD software to model semiconductor devices and processes</li> </ol>
<b>Topics Covered:</b>	<ol style="list-style-type: none"> <li>1. Review of semiconductor devices</li> <li>2. Organic semiconductor devices</li> <li>3. Carrier transport in low dimensional structure: quantum well, quantum wire and quantum dots</li> <li>4. Quantum effect devices (nanoscale devices)</li> <li>5. Introduction to scanning probe microscope: STM</li> <li>6. Vibration</li> <li>7. Scanning force microscope: non-contact AFM, dynamic EFM and MFM</li> <li>8. Field emission structure and devices</li> <li>9. Computer simulation and modeling of semiconductors using TCAD</li> </ol>
<b>Course Outcomes:</b>	Students will be able to: A-1. Draw band structure and density of state as a function of energy for 1-D, 2-D, and 3-D single free electron in macroscopic and quantum effect system. A-3. Identify the various scattering mechanisms of electrons in a crystal and describe how they impact electron transport. A-4. Apply quantum principles to multiple-quantum well semiconductor lasers, quantum dot resonant tunneling devices, and high speed hetero-structure devices.

	E-3. Use TCAD to model and simulate semiconductor devices. J-2. Describe economic characteristics of organic solar cells and LED devices as they relate to the production and consumption of energy. K-1. Set up and operate AFM for micro- and nano-scale measurements. K-4. Analyze the relationship between surface material properties and the AFM tip, vibration frequency, phase and amplitude using appropriate software tools.		
<b>Required or Elective Course:</b>	Elective		
<b>Contribution to Professional Component:</b>	Engineering Topics		
<b>Relationship of Course to Program:</b>	Meets: Educational Objectives <u>1, 2, 3, 4</u> Program Outcomes <u>A, E, J, K</u>		
<b>Prepared by:</b>	Dr. Daniel Chiang	Date:	November 1, 2006
<b>Approved by CAC:</b>			